



Attorney's Docket No.: 10417-084001 / F51-134741M/KIK

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Izuo Iida
Serial No. : 091876,554
Filed : June 7, 2001
Title : METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE

Art Unit : Unknown
Examiner : Unknown

Attention: Official Draftsman
Commissioner for Patents
Washington, D.C. 20231

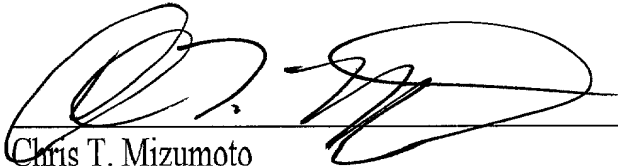
TRANSMITTAL OF FORMAL DRAWINGS

Please substitute the enclosed 12 sheets of formal drawings for the corresponding drawings presently in the application.

Please apply any charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Date: June 18, 2001

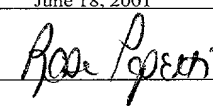

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FIG.1

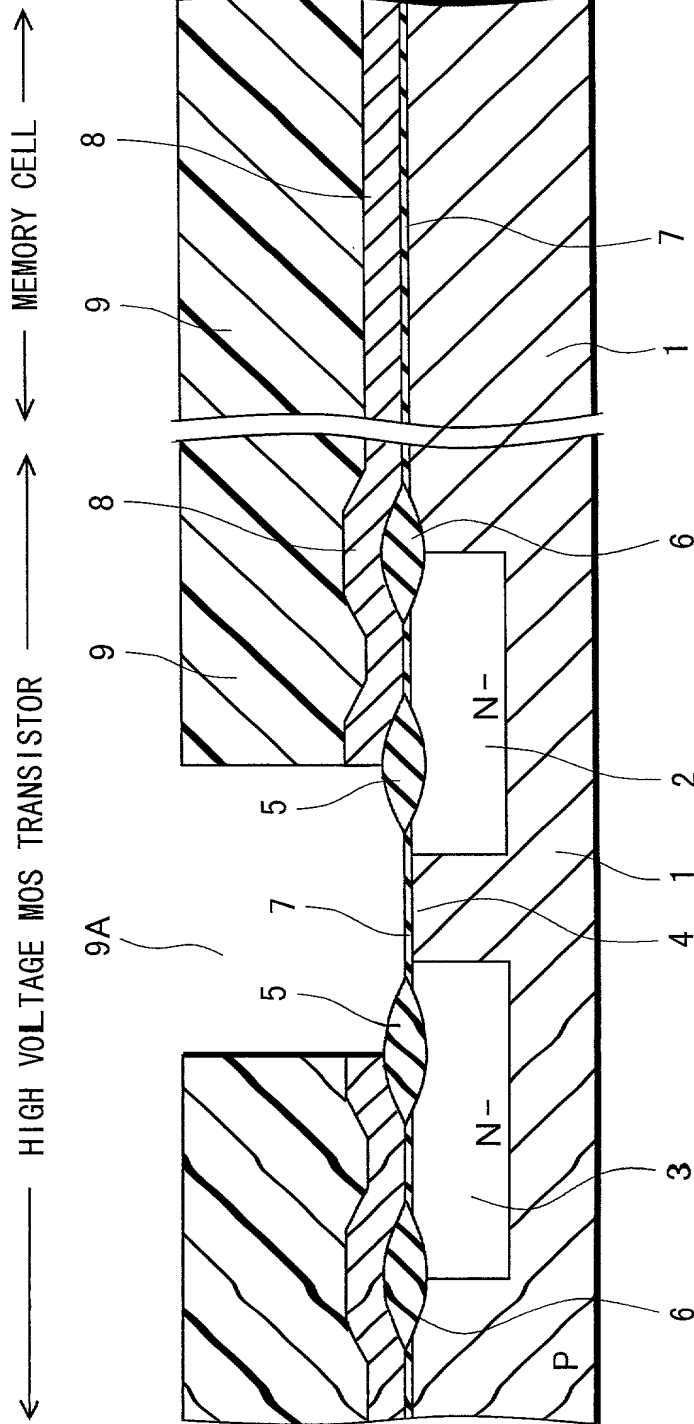


FIG.2

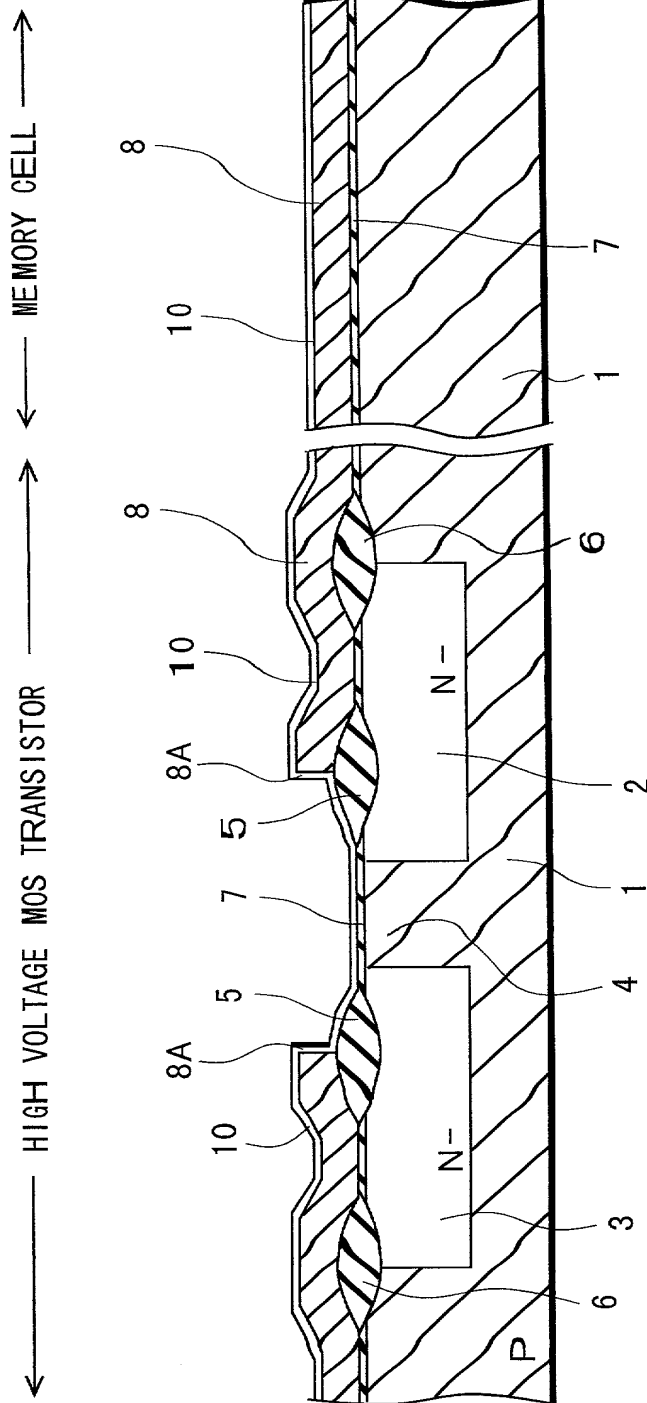


FIG.3

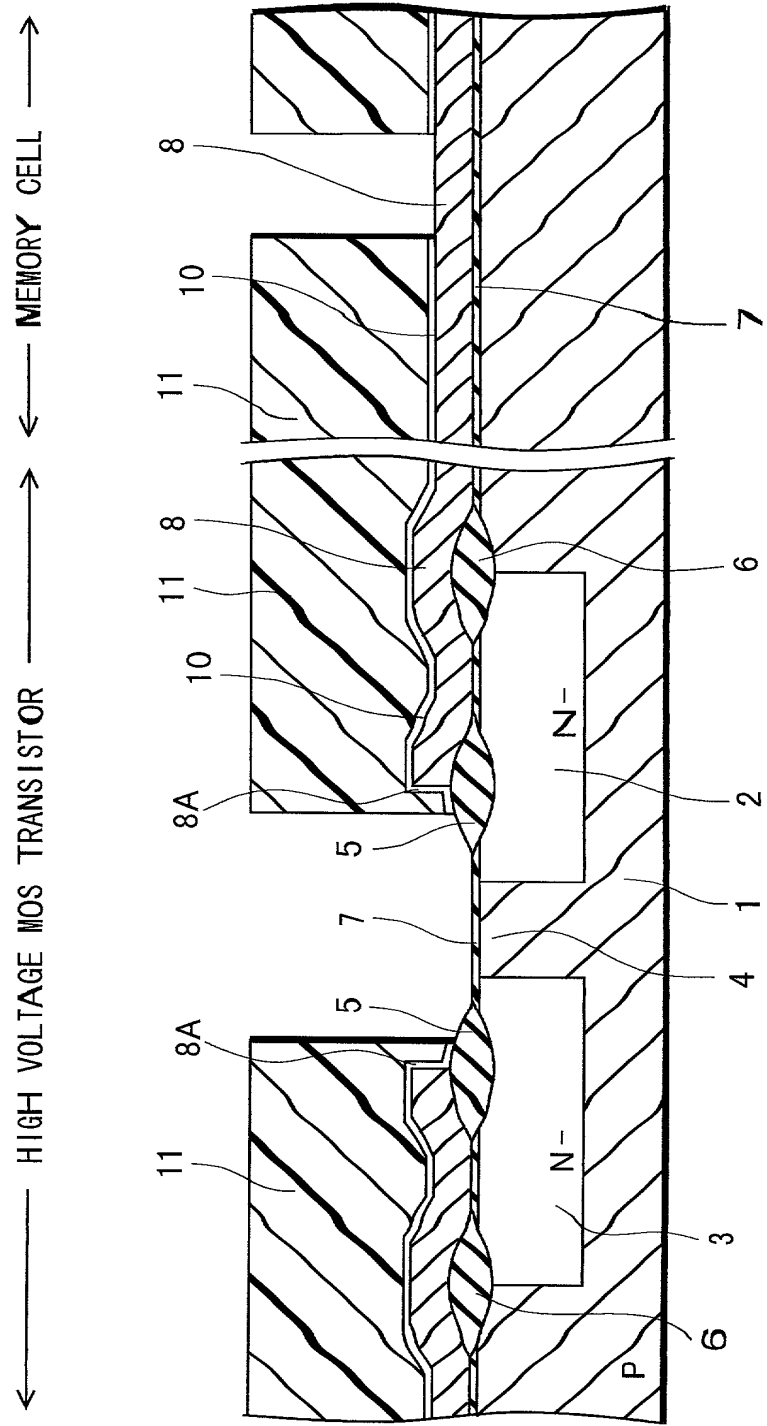


FIG.4

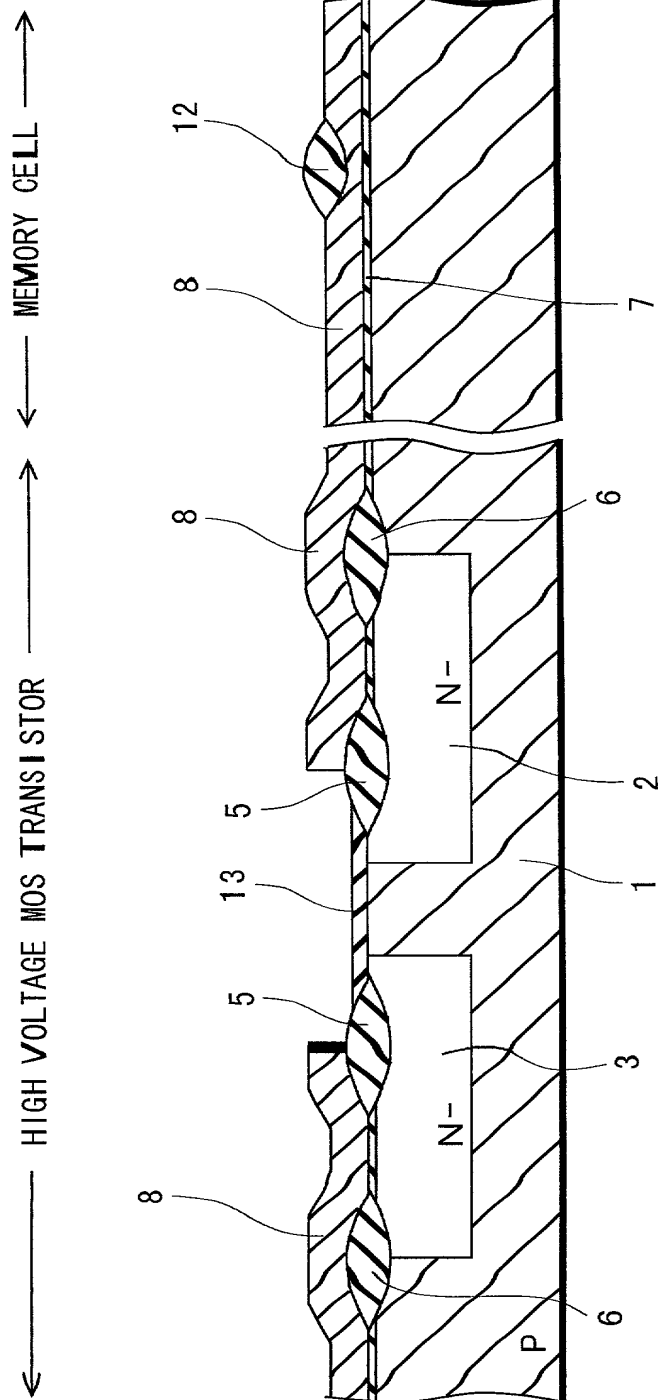


FIG.5

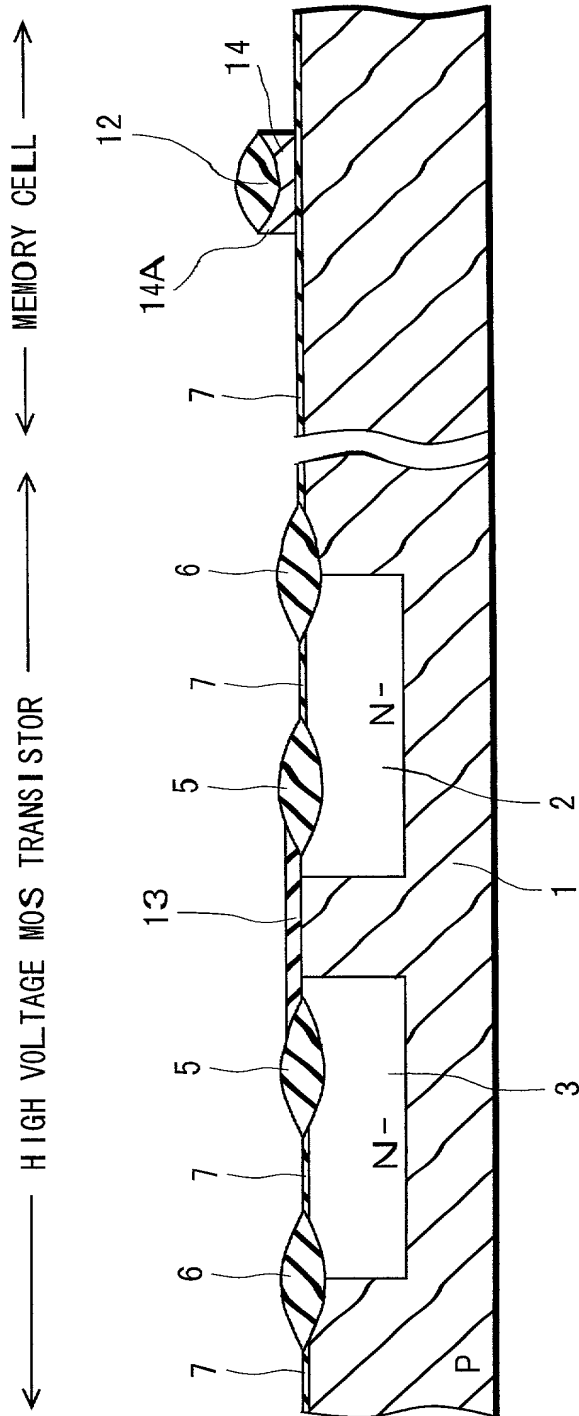


FIG.6

← HIGH VOLTAGE MOS TRANSISTOR → ← MEMORY CELL →

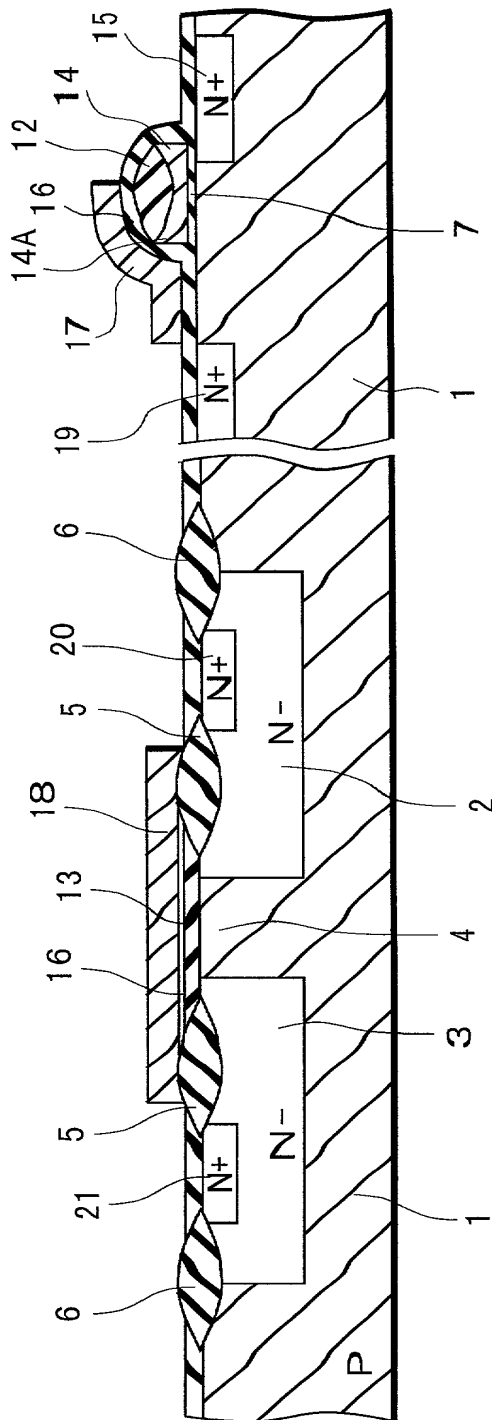


FIG.7

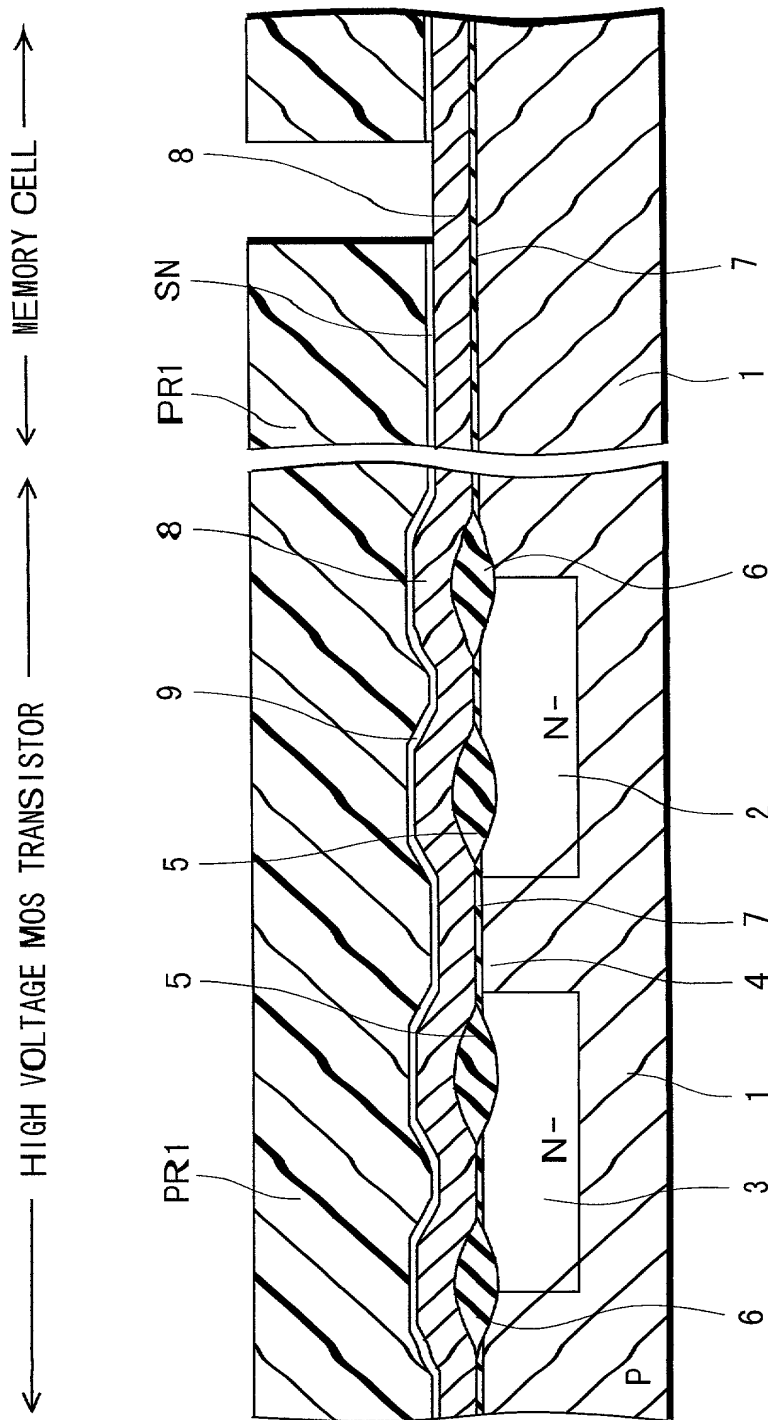


FIG.8

← HIGH VOLTAGE MOS TRANSISTOR → ← MEMORY CELL →

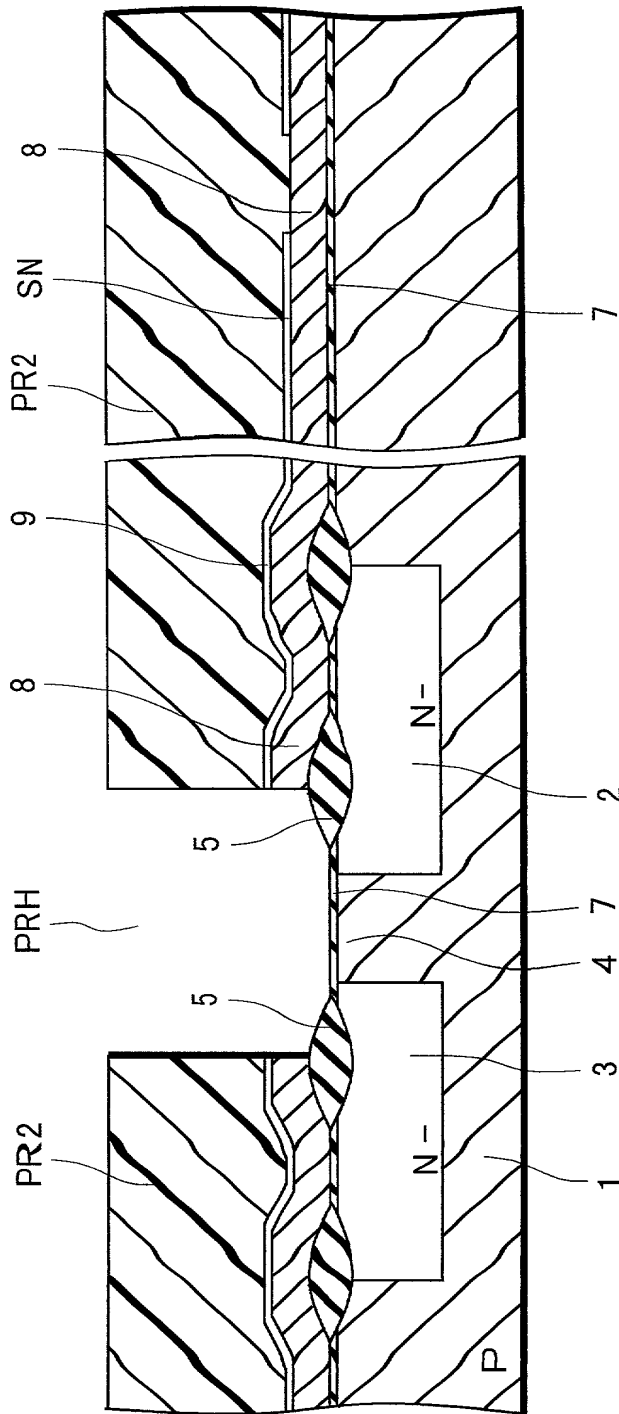


FIG. 9

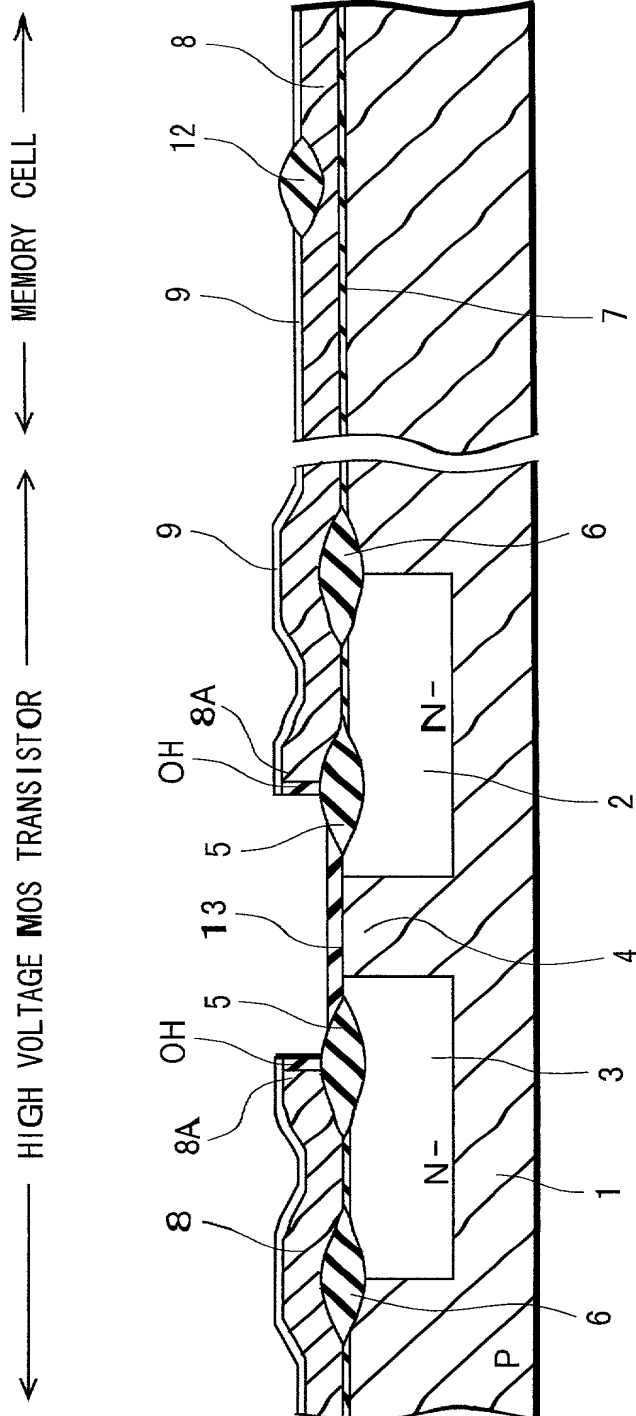


FIG.10

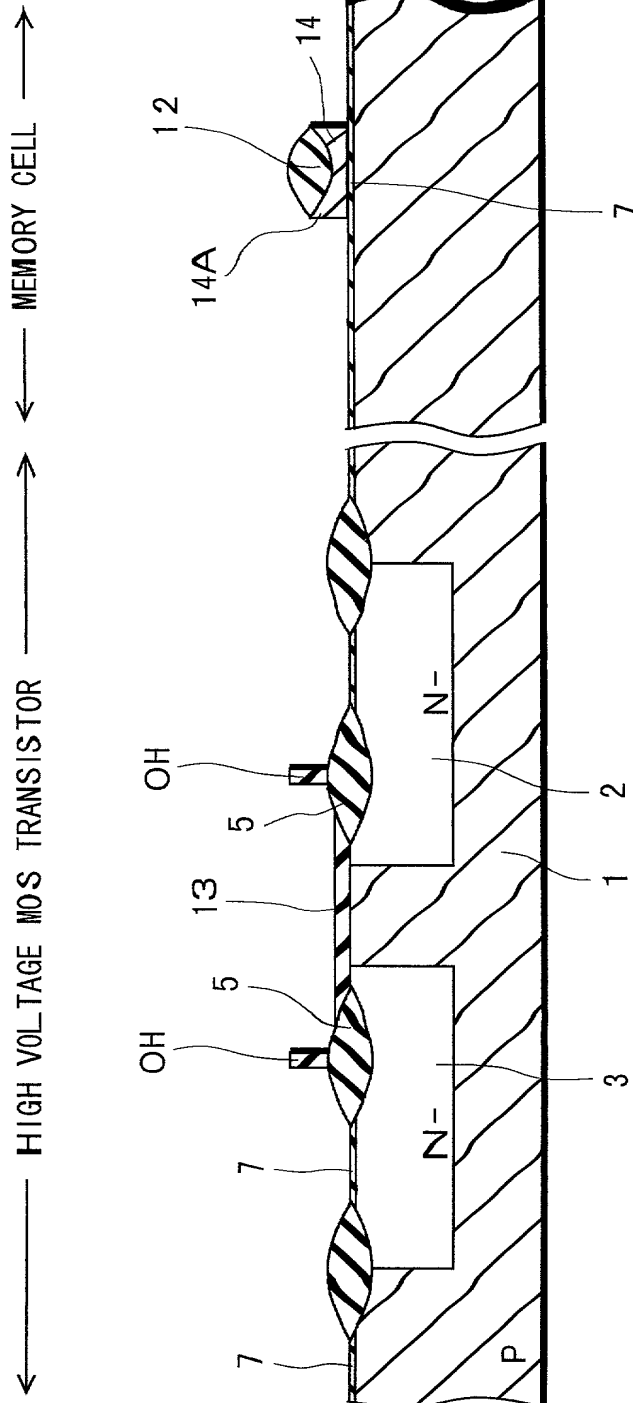


FIG. 11

